

Erratum

Erratum: Bartmański et al. Electrophoretic Deposition and Characteristics of Chitosan–Nanosilver Composite Coatings on a Nanotubular TiO₂ Layer. *Coatings* 2020, 10, 245

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The authors wish to make the following change to their published paper [1]. On page 1, the information about the corresponding author has been changed:

“* Corresponding: andrzej.zielinski@pg.edu.pl; Tel.: +(48)-501-329-368” is replaced by: “* Corresponding: michał.bartmanski@pg.edu.pl; Tel.: +48-500-034-220”.

The manuscript will be updated and the original will remain available. A link to this Erratum will be added.



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